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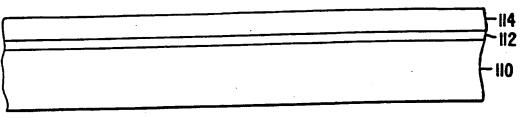


FIG. IA.

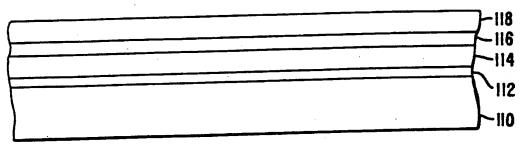


FIG. IB.

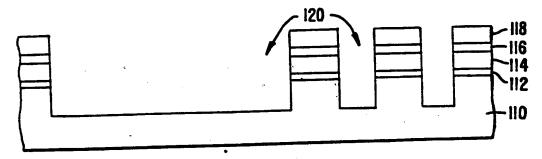


FIG. IC.

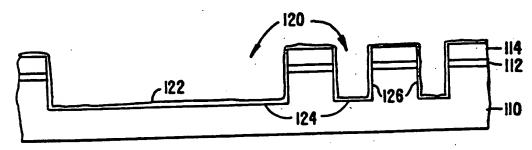
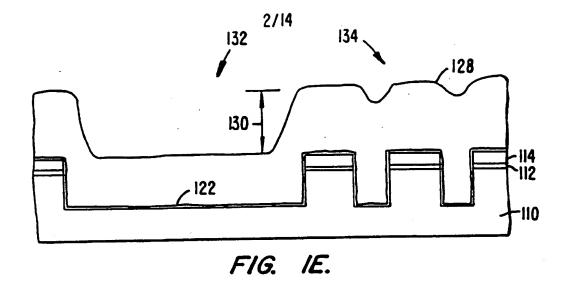
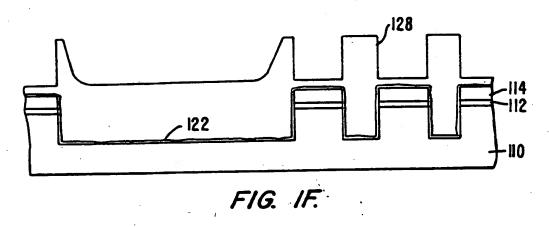


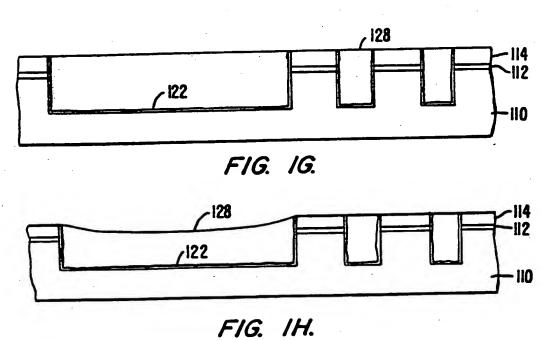
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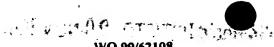
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FIG. 2A.

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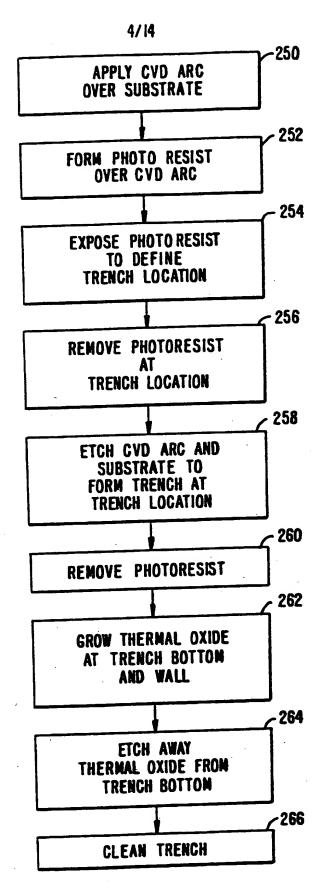
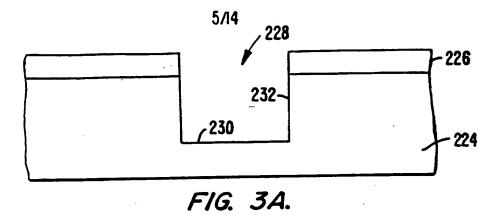
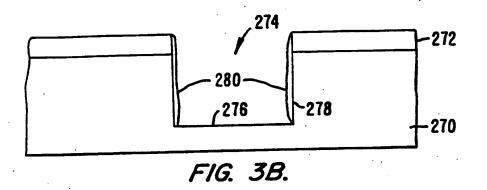


FIG. 2B.

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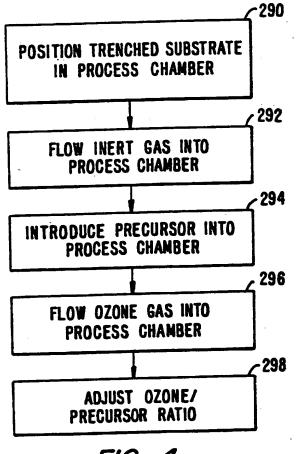
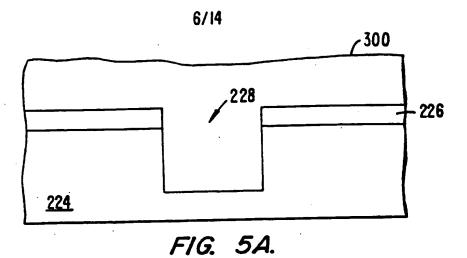


FIG. 4.

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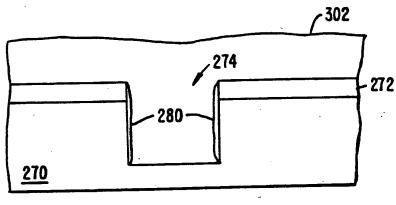


FIG. 5B.

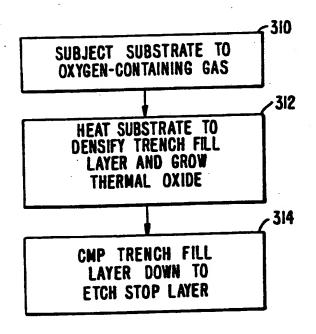


FIG. 6.

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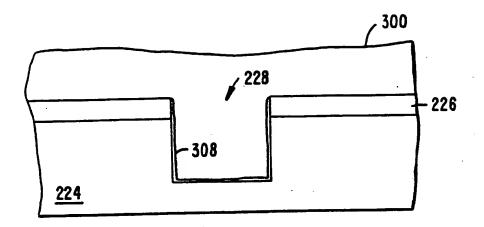
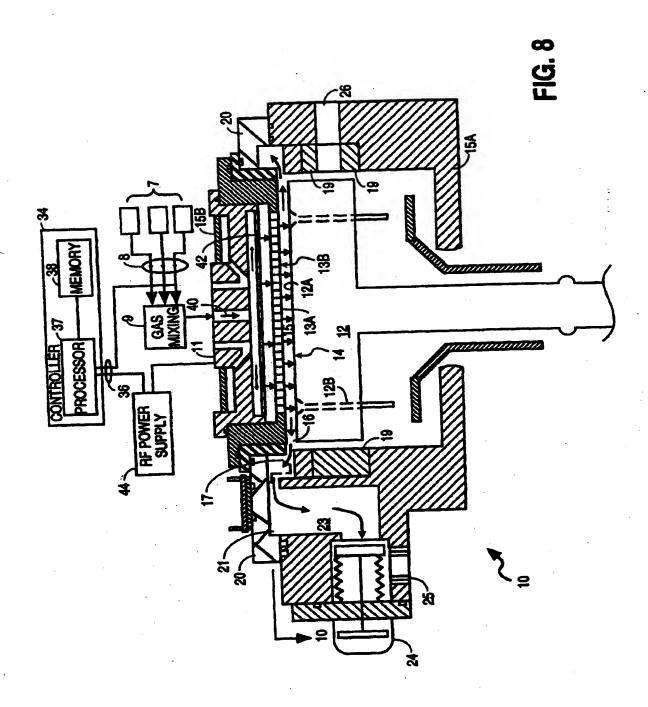


FIG. 7.

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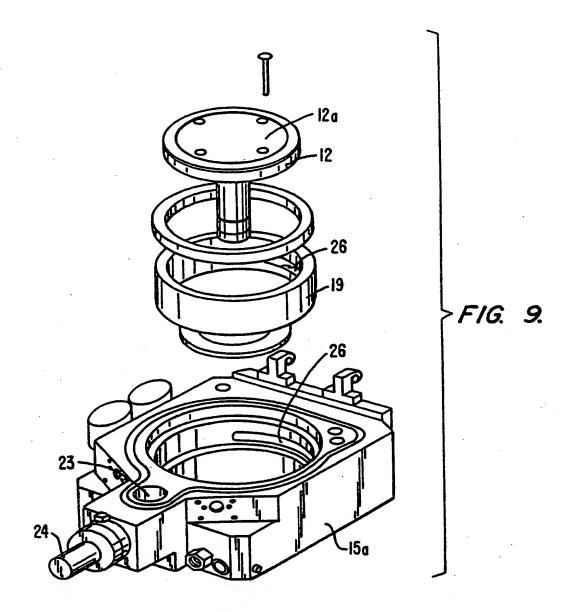
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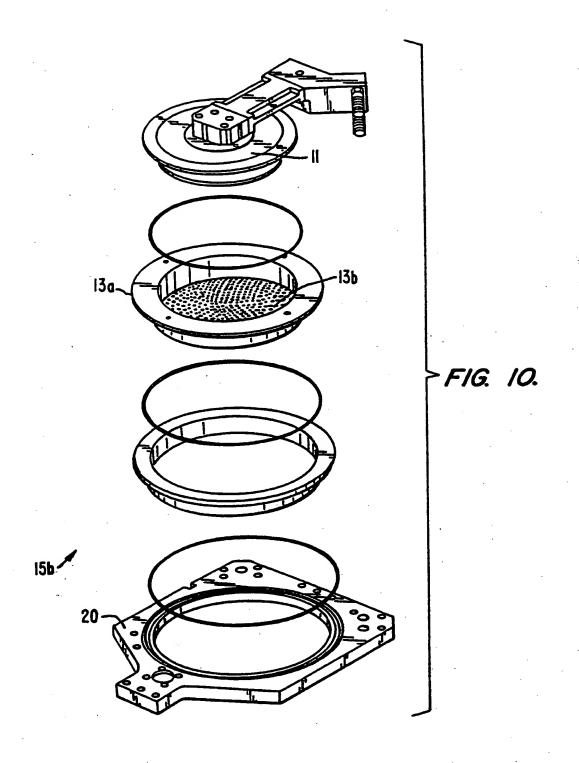
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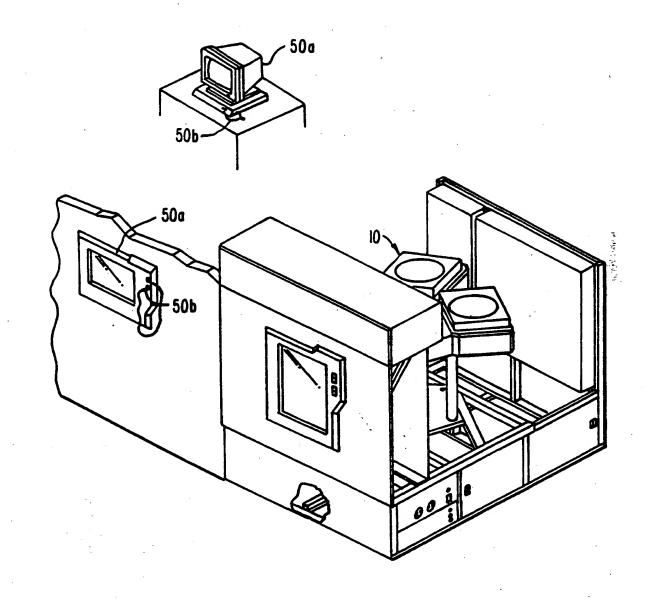


FIG. 11.

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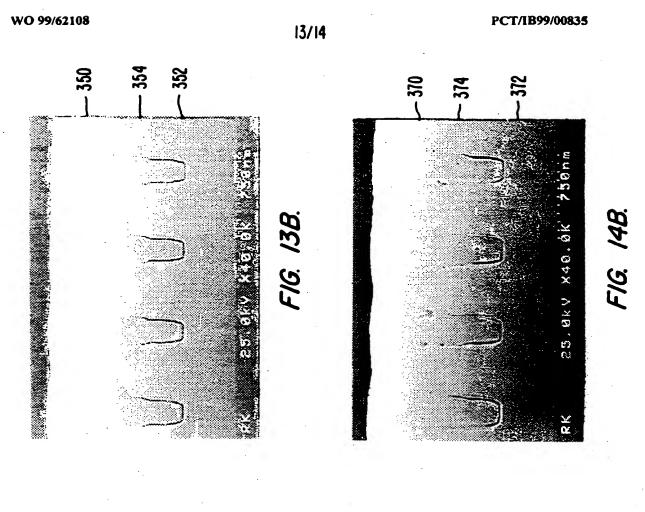
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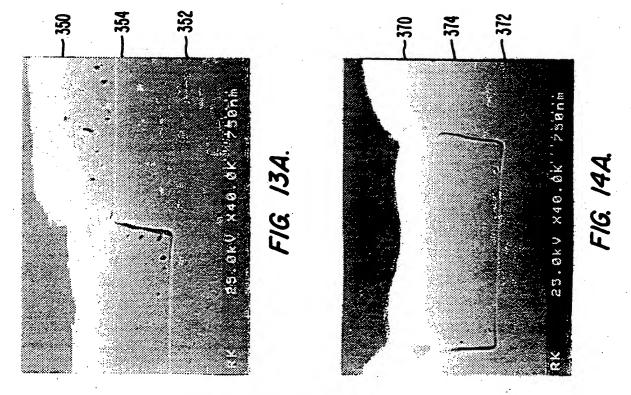
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12/14 PLASMA CONTROL CHAMBER MANAGER HEATER CONTROL CHAMBER MANAGER FOR CVD/SPUTTERING CHAMBER PRESSURE CONTROL PROCESS SEQUENCER PROCESS GAS CONTROL CHAMBER SELECTION PROCESS GAS FLOW TEMPERATURE PRESSURE PLASMA POWER CHAMBER MANAGER PROCESS SELECTOR SUBSTRATE Positioning

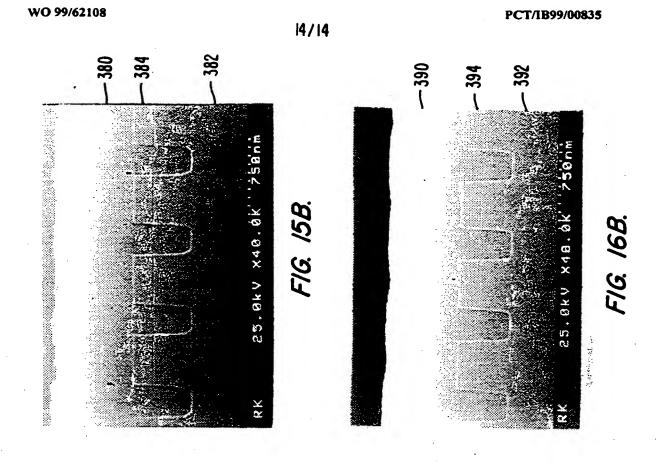
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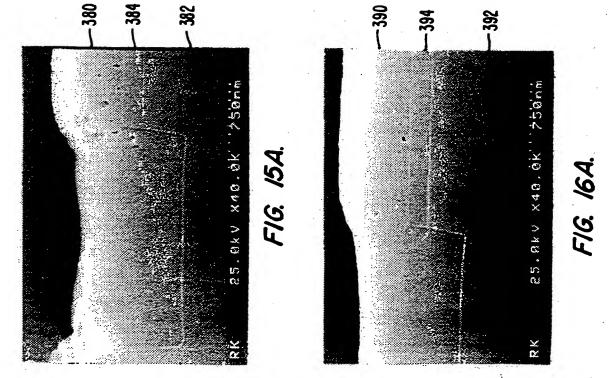




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